### Control

Stepping motor

and

Displacement sensor

and

Actuators

Dan Chen 2013/11/26 Cryo-payload meeting

# Test of actuator for initial alignment in cryogenic temperature

| 82 | 1.5.1   | Stepping motor (ICRR)           | 134日  | 13/11/18 (月) 14/03/31 (月)      | 8%    | 8%  | Chen Dan                                       |
|----|---------|---------------------------------|-------|--------------------------------|-------|-----|--|
| 83 | 1.5.1.1 | Candidate list                  | 27日   | 13/12/05 (木) 13/12/31 (火)      | 50%   | 50% | Sekiguchi<br>Takanori,Takahashi<br>R.,Chen Dan |
| 84 | 1.5.1.2 | Procurement of candidates       | 78日   | 13/11/29 (金) 14/02/14 (金)      | 0%    | 0%  | Takahashi<br>R.,Yamamoto<br>Kazuhiro           |
| 85 | 1.5.1.3 | Preparation for candidates test | 26日   | 13/11/18 (月) 13/12/13 (金)      | 0%    | 0%  | Chen Dan,Student<br>from AEI Hannover          |
| 86 | 1.5.1.4 | Test at cryo temp               | 1.43月 | 14/02/17 (月) 14/03/31 (月) 84,8 | 35 0% | 0%  | To be determined<br>(ICRR),Small<br>cryostat   |

#### Status

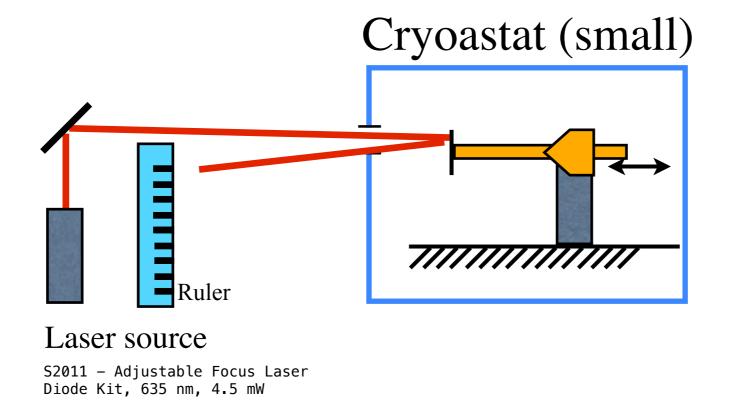
| Candidate list       | We made.        |  |  |  |
|----------------------|-----------------|--|--|--|
| Procurement          |                 |  |  |  |
| Preparation for test | Now in progress |  |  |  |
| Cryo test            | Not yet         |  |  |  |

### Actuator for initial alignment

| Name           | Number we have in ICRR | comment   |
|----------------|------------------------|---|
| Stepping motor | 0                      | The delivery time is 2.5 month. The counpany said this works at 4K.   |
| Pico motor     | 1                      | We will have quick experiment via PT cryocooler.  |
| Autex          | 0                      | Actuator with stage. A sales representative will come tomorrow. (15:00-@TV-conference room in the north side of ICRR building.) |

#### Quick test of the Pico motor at low temperature.





Laser source is deliveried.

We can start this measurement now.

# Test of Displacement sensor and actuators (OSEM) in cryogenic temperature

| 87 | 1.5.2   | Displacement sensor and actuators<br>(between Intermediate Mass and<br>Intermediate Recoil Mass) (ICRR) | 117日 | 13/11/04 (月) 14/02/28 (金)       | 0% | 0% | Chen Dan  |
|----|---------|---|------|---------------------------------|----|----|---|
| 88 | 1.5.2.1 | Candidate list of light sources and<br>photo diodes   | 12日  | 13/11/04 (月) 13/11/15 (金)       | 0% | 0% | Suzuki T,Takahashi<br>R,Yamamoto<br>Kazuhiro,Chen Dan |
| 89 | 1.5.2.2 | Procurement of candidates of light<br>sources and photo diode   | 26日  | 13/11/16 (土) 13/12/11 (水) 88    | 0% | 0% | Chen Dan  |
| 90 | 1.5.2.3 | Preparation of test for the<br>candidates of light sources and<br>photo diode                           | 12日  | 13/11/29 (金) 13/12/10 (火)       | 0% | 0% | Chen Dan, Student<br>from AEI Hannover                |
| 91 | 1.5.2.4 | Test for the candidates of light<br>sources and photo diode   | 20日  | 13/12/12 (木) 13/12/31 (火) 90,89 | 0% | 0% | Chen Dan,Small<br>cryostat                            |
| 92 | 1.5.2.5 | Preparation for test of sensor  | 27日  | 13/11/17(日)13/12/13(金)          | 0% | 0% | Student from AEI<br>Hannover                          |
| 93 | 1.5.2.6 | Test of sensor at cryogenic<br>temperature  | 54日  | 14/01/06 (月) 14/02/28 (金) 92    | 0% | 0% | To be determined<br>(ICRR),Small<br>cryostat          |

#### Status

| Candidate list | We made. (are making.)      |
|----------------|-----------------------------|
| Procurement    |                             |
| Preparation    | Apparatus for FGA21 are OK. |
| Cryo test      | FGA21 are in progress.      |

### PD

| Name     | Туре             | Peak    | Number we have in ICRR | comment  |
|----------|------------------|---------|------------------------|--|
| S1223-01 | Si PIN<br>PD     | 960 nm  | 5                      | This is used in OSEM at room temperature. The quantam efficiency decreases at low T(1->1/5). |
| G8370-01 | InGaAs<br>PIN PD | 1550 nm | 0                      | Tomaru-san said this works at low T. I asked a quotation but is was out of stock.            |
| FGA21    | InGaAs<br>Pin PD | 1600 nm | 2                      | The quantum efficiency decreases at low $T(1->1/8)$ .  |

### LED

| Name      | Type    | Peak    | Number we have in ICRR | comment  |
|-----------|---------|---------|------------------------|--|
| OP232     | GaAIAs  | 890 nm  | 5                      | This is used in OSEM at room temperature.                    |
| L2656-03  | GaAlAs  | 890 nm  | 0                      | Tomaru-san said this works at low T. I will ask a quotation. |
| ML925B45F | InGaAsP | 1550 nm | 2(?)                   |  |

## Test of Displacement sensor and actuators (OSEM) in cryogenic temperature

- Attocube might know PD for cryogenic temperature.

  Manuela will ask them.
- Several LEDs are deliveried. We will test it at 77K.

### A/I on 19th Nov

- (a)Dan will ask Takashi whether picomotor can survive at cryogenic temperature.

  The Picomotor didn't work at 77K. But that might be because of the cooling shock.

  So we will have quick cooling test.
- (b)Dan look for design drawing of stage for Type B and commercial stage. I receaved the design drwing from Takanori.
- (c)Kazuhiro considers schedule again.

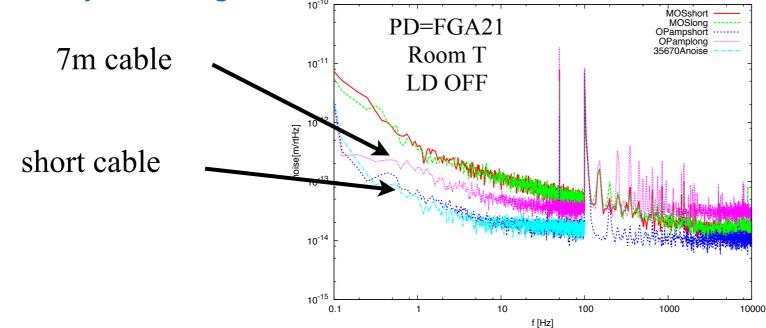
  The schedule is in the above alides.
- (d)Kazuhiro consult Ryutaro (procurement of OSEM).

Have we ordered?

- (e)Suzuki-san? check whether thrust bearing can work at cryogenic temperature.
- (f)Some concerns; out gas, noise by 10m long line (according to Dan's experiment in Toshiba, it does not matter), must the window of photo diode be removed?

The gas in the PD(S1223-01) is nitrogen. So we have to remove the window.

Noise by 10m long line:



We have to take care.